## PATENT APPLICATION

Group Art Unit: 2814

S. Rao

Examiner:

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki ABE et al.

Application No.: 08/930,449

Filed: September 30, 1997

Docket No.: JAO 39514

HIGH ENERGY SUPPLY APPARATUS, METHOD OF FORMING CRYSTALLINE FILM AND METHOD OF MANUFACTURING THIN FILM ELECTRONIC DEVICE

## REQUEST FOR APPROVAL OF DRAWING CORRECTIONS

**Assistant Commissioner for Patents** Washington, D.C. 20231

Sir:

For:

The Examiner is requested to review and approve the proposed corrections to Figures 3 and 8, marked in red on the attached copy of such drawing figures.

Upon approval by the Examiner, and upon allowance of this application, the formal drawings will be corrected.

Respectfully submitted,

James A. Oliff

Registration No. 27,075

Edward A. Brown

Registration No. 35,033

JAO:EAB\jth

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400